

Sheet 1 of 1

Substitute Form PTO-1449 (Modified)  <b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)  (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office		Attorney's Docket No. 12406-059US2	Application No. 10/625,118
	Applicant Volker Haerle			
	Filing Date July 22, 2003		Group Art Unit 2824	

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AJ						
	AJ						
	AK						



Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL	JP 5006880	01/1993	JP			Abstract	
	AM	JP 5160085	06/1993	JP			Abstract	
	AN	JP 6224153	05/1994	JP			Abstract	
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)		
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EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Substitute Disclosure Form (PTO-1449)

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Attorney's Docket No. 12406-059US2		Mailing Date June 2, 2004	<b>For PTO Use Only</b> Do Not Mark in This Area  
Application No. 10/625,118	Filing Date July 22, 2003	Attorney/Secretary Init DJG/JAZ/cab	
Title of the Invention METHOD OF PRODUCTION OF SEMICONDUCTOR COMPONENTS			
Applicant Volker Haerle			
Client Reference No. 1998P1821 US2 N			
Enclosures · Information Disclosure Statement (1 page) · Form PTO-1449 (1 page) · Documents listed on the Form PTO-1449 (3 documents) · Return Receipt Postcard 			

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